



Automation Technology Japan TC Chapter

Meeting Summary and Minutes

Japan Summer Meetings 2023

Friday, June 23, 2023 13:30 – 15:00 [JST]

OVTCCM/ SEMI Japan Office, Tokyo, Japan (Hybrid)

TC Chapter Announcements

Next TC Chapter Meeting

Wednesday, December 20, 2023 13:30-17:00 [JST]

OVTCCM/ SEMI Japan Office, Tokyo, Japan (Hybrid)

Table 1 Meeting Attendees

Italics indicate virtual participants.

Co-Chairs: Fumiyasu Ohbuchi/ Siemens Japan, Terry Asakawa/ Vistaideal Consulting

SEMI Staff: Akiko Yoshida (SEMI Japan)

<i>Company</i>	<i>Last</i>	<i>First</i>	<i>Company</i>	<i>Last</i>	<i>First</i>
<i>CKD</i>	<i>Futamura</i>	<i>Ikuo</i>	<i>Siemens Japan</i>	<i>Ohbuchi</i>	<i>Fumiyasu</i>
<i>FUJI</i>	<i>Minoshima</i>	<i>Nobuaki</i>	<i>Vistaideal Consulting</i>	<i>Asakawa</i>	<i>Terry</i>
<i>Panasonic Connect</i>	<i>Inoue</i>	<i>Takahiro</i>	<i>Yokogawa Digital</i>	<i>Nakagawa</i>	<i>Takashi</i>
<i>PEER Group</i>	<i>Fuchigami</i>	<i>Albert</i>	<i>Yokogawa Digital</i>	<i>Yamaki</i>	<i>Takeo</i>
SEMI Japan	Yoshida	Akiko			

Table 2 Leadership Changes

<i>WG/TF/SC/TC Name</i>	<i>Previous Leader</i>	<i>New Leader</i>
None		

Table 3 TC Chapter Structure Changes

<i>Previous WG/TF/SC Name</i>	<i>New WG/TF/SC Name or Status Change</i>
None	

Table 4 Ballot Results

<i>Document #</i>	<i>Document Title</i>	<i>Committee Action</i>
None		

#1 **Passed** ballots and line items will be submitted to the ISC Audit & Review Subcommittee for procedural review.

#2 **Failed** ballots and line items were returned to the originating task forces for re-work and re-balloting or abandoning.



Table 5 Ratification Ballot Results

<i>Document #</i>	<i>Document Title</i>	<i>ISC A&R Action</i>	<i>A&R Forms</i>
None			

Note 1: **Passed** Ratification ballots will be submitted to SEMI publication for final processing.

Note 2: **Failed** Ratification ballots were returned to the originating task forces for re-work and re-balloting or abandoning.

Table 6 Activities Approved by the GCS between meetings of the TC Chapter

<i>#</i>	<i>Type</i>	<i>SC/TF/WG</i>	<i>Details</i>
None			

Table 7 Authorized Activities

Listing of all revised or new SNARF(s) approved by the Originating TC Chapter.

<i>#</i>	<i>Type</i>	<i>SC/TF/WG</i>	<i>Details</i>
None			

#1 SNARFs and TFOFs are available for review on the SEMI Web site at:

<http://downloads.semi.org/web/wstdsbal.nsf/TFOFSNARF>

Table 8 Authorized Ballots

<i>#</i>	<i>When</i>	<i>TF</i>	<i>Details</i>
None			

Table 9 SNARF(s) Granted a One-Year Extension

<i>#</i>	<i>TF</i>	<i>Title</i>	<i>Expiration Date</i>
None			

Table 10 SNARF(s) Abolished

<i>#</i>	<i>TF</i>	<i>Title</i>
None		

Table 11 Standard(s) to receive Inactive Status

<i>Standard Designation</i>	<i>Title</i>
None	

Table 12 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
None		

Table 13 Previous Meeting Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
None		



1 Welcome, Reminders, and Introductions

Ohbuchi Fumiyasu (Siemens Japan) called the meeting to order at 13:30. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed. Attendees introduced themselves.

Attachment: 01_Meeting Reminders

2 Review of Previous Meeting Minutes

The TC Chapter reviewed the minutes of the previous meeting.

Motion: Approve the minutes as written.
By / 2nd: Nobuaki Minoshima (FUJI)/ Takeo Yamaki (Yokogawa Digital)
Discussion: None.
Vote: 6-0. Motion passed.

Attachment: 02_AT Japan_Minutes_221223

3 Liaison Reports

3.1 *Automation Technology Taiwan TC Chapter*

Akiko Yoshida (SEMI Japan) reported for the Automation Technology Taiwan TC Chapter that there had been no updates from the previous meeting.

3.2 *Flow Manufacturing Forum*

Ohbuchi Fumiyasu (Siemens Japan) reported for the Flow Manufacturing Forum. The forum met on May 19 online and discussed the planned booths at the exhibition called JISSO PROTEC and how to promote SEMI SMT-ELS. The next meeting will be held online on July 14.

4 SEMI Staff Report

Akiko Yoshida (SEMI Japan) gave the SEMI Staff Report. Of note:

- SEMI University (SEMI Global e-learning platform) was launched in early February 2023 providing 360+ on-demand courses created specifically for the semiconductor industry.
- A new staff joined SEMI as a publication specialist in May.

Attachment: 03_Staff Report July 2023 v1

5 Ballot Review

None.

6 Subcommittee and Task Force Reports

6.1 *A1 Task Force*

Takeo Yamaki (Yokogawa Digital) reported for the A1 Task Force. The TF has not met since January last year, so there has been no updates.

Attachment: 04_A1 TF Report_20230623



6.2 Surface Mount Technology (SMT) Task Force

Nobuaki Minoshima (FUJI) reported for the Surface Mount Technology (SMT) Task Force. The TF has been working on Doc.#6827 (Line Item Revision to SEMI A2-0521, Specification for Surface Mount Assembler Smart Hookup (SMASH)). Although the TF first intended to submit Doc.#6827 for cycle 6, they will finalize the document in time for cycle 7 (Ballot submission: August 30, Voting period: September 13 through October 13). To do so, he said that the TF would ask Automation Technology GCS to authorize the issuance of the ballot for cycle 7. Terry Asakawa (Vistaideal Consulting) advised that Fumiyasu Ohbuchi (Siemens Japan), who is a GCS voting member, to talk with Taiwan TC Chapter co-chairs on this proposed document in advance for smooth communication.

Attachment: 05_SMT TF Report_2023_0623

6.3 F-GEM Task Force

Takeo Yamaki (Yokogawa Digital) reported for the F-GEM Task Force. The TF met online on June 20 and discussed events that occur in each equipment and panel product. The TF will meet on July 25 to continuously consider the scenario.

Attachment: 06_F-GEM TF Report_20230623

7 Old Business

7.1 Project Period Review

None.

7.2 5-year Review

None.

8 New Business

None.

9 Action Item Review

9.1 Open Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
None		

9.2 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
None		

10 Next Meeting and Adjournment

The next meeting is scheduled for Wednesday, December 20, 2023 13:30-17:00 via OVTCCM and at SEMI Japan Office, Tokyo, Japan. See <http://www.semi.org/standards-events> for the current list of events.

Adjournment: [14:43].



Respectfully submitted by:

Akiko Yoshida

Standards & EHS

SEMI Japan

Phone: +81-3-3222-5863

Email: ayoshida@semi.org

Minutes tentatively approved by:

Fumiyasu Ohbuchi (Siemens Japan), Co-chair	July 14, 2023
Yasuhiro Kaneko (YAMAHA Motor), Co-chair	-
Terry Asakawa (Vistaideal Consulting), Co-chair	-

Table 14 Index of Available Attachments^{#1}

<i>Title</i>	<i>Title</i>
01_Meeting Reminders	04_A1 TF Report_20230623
02_AT Japan_Minutes_221223	05_SMT TF Report_2023_0623
03_Staff Report July 2023 v1	06_F-GEM TF Report_20230623

#1 Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact Akiko Yoshida at the contact information above.